

Supporting Information

Templated 3D ultrathin CVD graphite networks with controllable geometry: synthesis and application as supercapacitor electrodes

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Experimental Details

Sample Preparation

Silicon (100) substrates, 6" in diameter, are cleaned via a rinse in piranha solution (50:1 $\text{H}_2\text{SO}_4:\text{H}_2\text{O}_2$, 120 °C), followed sequentially by rinses with deionized (DI) water, concentrated HF solution, and DI water. A 100 nm layer of Ni, with a 5 nm Ti adhesion layer, is deposited onto the Si wafer in an e-beam evaporator (Thermionics). This metal layer serves as the seed for subsequent Ni electrodeposition. The wafer is diced into $1.5 \times 1 \text{ cm}^2$ chips and cleaned with ultrasonication in acetone followed by sequential rinses with isopropyl alcohol and DI water.

Microsphere Deposition

Suspensions of polystyrene spheres of 1 μm and 0.5 μm diameters (Thermo Scientific) are diluted to 1 wt% colloidal suspensions in a 1:1 by weight ethanol to DI water ratio. The sample is partially immersed into a beaker filled with water and the diluted suspension is deposited onto the water surface via micropipette. A drop of 3% sodium dodecyl sulfate solution is used to order the spheres on the surface into a close-packed array. The sample is slowly withdrawn from the beaker, leaving a monolayer of spheres on the Ni surface, then dried and annealed for 30 seconds at 100 °C on a hot plate. The process is repeated to add additional layers of spheres. After the desired number of layers is deposited, the sample is annealed for 5 minutes at 100 °C on a hot plate in order to partially sinter the spheres together.

Electrodeposition of Ni

A high throwing power Ni sulfate bath (composed of 0.775 M NiSO_4 , 1.173 M NiCl_2 , 2.534 M NaSO_4 , and 0.809 M boric acid) is used for the electrodeposition.¹ The deposition is performed with stirring at room temperature, using a deposition current of 3 mA/cm^2 and a Ni wire counter

electrode. After deposition of the desired amount of Ni, the sample is immersed in tetrahydrofuran (Sigma-Aldrich) overnight to dissolve the polystyrene spheres.

Ultrathin graphite growth

After loading the sample in the center of a hot-wall CVD tube furnace (Thermo Scientific Lindberg Blue M), a crucible with 1 mL benzene (Sigma-Aldrich) is placed near the inlet. The crucible is covered with aluminum foil with a small hole (diameter ~ 1 mm). After flowing 200 sccm of Ar (Praxair) for 10 min at ambient pressure, H₂ gas (Praxair) is introduced at a 65 sccm flow rate, and the temperature is raised to 600 °C at ~ 40 °C/min under a combined H₂ and Ar flow. Once the furnace reaches the desired temperature, the furnace is turned off, and the sample is then allowed to cool at a rate of ~ 25 °C/min in the H₂ + Ar flow to yield a multilayer graphene which has sufficient mechanical stability for a free-standing foam, without polymer supports required for transfer.² After deposition, the Ni is etched overnight in concentrated 12 M HCl. Upon etching, the freestanding carbon foam floats to the surface, where it is scooped up by another substrate (polycarbonate sheets in this case).

Calculation of energy and power density

The reported energy and power density are calculated from the cyclic voltammetry data at a scan rate of 50 mV/s and 10 V/s respectively using the following formulae:

$$E = \frac{1}{2} CV^2$$

$$P = \frac{E}{\Delta t}$$

where E is the energy density, P is the power density, C is the specific capacitance (either areal or volumetric), V is the voltage window scanned (0.8 V), and Δt is the discharge time.

References:

- (1) Di Bari, G. A., In *Modern Electroplating*; Schlesinger, M., Paunovic, M., Eds.; John Wiley & Sons, Inc.: Hoboken, NJ, 2010; Chapter 3, pp 79-114.
- (2) Ji, H.; Zhang, L.; Pettes, M. T.; Li, H.; Chen, S.; Shi, L.; Piner, R.; Ruoff, R. S. Ultrathin Graphite Foam: a Three-Dimensional Conductive Network for Battery Electrodes. *Nano Letters* **2012**, *12*, 2446-2451.